

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Takeshi SAKAMOTO <i>et al.</i>)	Confirmation No.: 1891
)	
Application No.: 10/594,949)	Group Art Unit: 2893
)	
Filed: September 29, 2006)	Examiner: Kahn, Farid H.
)	
)	
For: LASER PROCESSING METHOD AND)	
SEMICONDUCTOR CHIP)	

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Alexandria, VA 22314

Sir:

AMENDMENT

In response to the Office Action dated April 14, 2009, please amend the above-identified application as follows: